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APPLICATION NO.	FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
10/613,513	07/03/2003		Brian Y. Lim	ATO-001.00	4790	
7	7590	08/11/2005		EXAMINER		
C George Yu		_		ELVE, MARIA	ALEXANDRA	
12707 High Bl Second Floor I				ART UNIT PAPER NUMBER		
San Diego, CA 92130			1725			
				DATE MAILED: 08/11/2009	5	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)	
	10/613,513	LIM ET AL.	
Office Action Summary	Examiner	Art Unit	
	M. Alexandra Elve	1725	
The MAILING DATE of this communication a Period for Reply	ppears on the cover sheet wi	th the correspondence address	•
A SHORTENED STATUTORY PERIOD FOR REP THE MAILING DATE OF THIS COMMUNICATION - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reful fixed for reply is specified above, the maximum statutory perional Failure to reply within the set or extended period for reply will, by state Any reply received by the Office later than three months after the mail earned patent term adjustment. See 37 CFR 1.704(b).	I. 1.136(a). In no event, however, may a reply within the statutory minimum of third will apply and will expire SIX (6) MON ute, cause the application to become AE	eply be timely filed y (30) days will be considered timely. THS from the mailing date of this communical ANDONED (35 U.S.C. § 133).	tion.
Status			
1) Responsive to communication(s) filed on 23	May 2005.		
<u> </u>	nis action is non-final.		
3) Since this application is in condition for allow		ers, prosecution as to the merits	is
closed in accordance with the practice under	•	· ·	
Disposition of Claims			
4)⊠ Claim(s) <u>1-28</u> is/are pending in the application	on.		
4a) Of the above claim(s) <u>19-28</u> is/are withdra	•		
5) Claim(s) is/are allowed.			
6)⊠ Claim(s) <u>1-18</u> is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction and	/or election requirement.	•	
Application Papers			
9) The specification is objected to by the Examir	ner		
10)⊠ The drawing(s) filed on <u>03 July 2003</u> is/are: a		ted to by the Examiner	
Applicant may not request that any objection to the			
Replacement drawing sheet(s) including the corre		, ,	1(d)
11) The oath or declaration is objected to by the I	· -	• •	• •
		. 6111667 (611611 61 76111 1 76 762.	•
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreig	gn priority under 35 U.S.C. §	119(a)-(d) or (f).	
a) All b) Some * c) None of:			
1. Certified copies of the priority docume	nts have been received.		
2. Certified copies of the priority docume	nts have been received in A	pplication No	
3. Copies of the certified copies of the pri	iority documents have been	received in this National Stage	
application from the International Bure	au (PCT Rule 17.2(a)).		
* See the attached detailed Office action for a list	st of the certified copies not	received.	
Attachment(s)			
1) Notice of References Cited (PTO-892)	4) Interview S	Summary (PTO-413)	
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s	s)/Mail Date	
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/0 Paper No(s)/Mail Date <u>5/23/05</u> .	(8) 5) ☐ Notice of I	nformal Patent Application (PTO-152)	
U.S. Patent and Trademark Office			

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DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Colbert et al. (US Pat. 6,756,026) in view of Haruta (USPN 6,110,291).

Colbert et al. discloses a system in which nanocomponents for nanodevices are made. The system has a mounting element such as a precision translation stage(s) having movement capabilities in the XYZ directions. Mounting requires a minimum of two precision stages. Carbon feedstock gas may be added into the reactor. A catalyst may be formed in-situ using temperatures of 400 to 2000 C. Heat can be supplied in a locally using a laser (e.g. argon), microwave energy, or R-F energy. (abstract, figures, col. 4, lines 44-58, col. 7, lines 12-40, col. 9, lines 30-54, col. 25, lines 1-31, col. 26, lines 34-50)

Colbert et al. does not teach multiple radiating energy beams (prongs) or the use of a beamsplitter.

Haruta et al. discloses a laser apparatus for forming thin films. The apparatus includes a laser, a chamber, a target, and a substrate holder. In an embodiment the target is laser evaporated in order to generate plumes; these plumes are deposited onto the substrate. In addition the embodiment has a beam splitter, a mirror, a linear moving

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stage and a linear moving stage controlling apparatus. The laser beam emitted from the laser unit is divided into a plurality of laser beams by means of a plurality beam splitter. which is directed into a plurality of mirrors, condensers, and inlet windows and then is incident onto a plurality of portions of the raw material target. This in turn generates plumes for deposition. (abstract, figures, col. 43-45)

It would have been obvious to one of ordinary skill in the art at the time of the invention to use a beamsplitter as taught by Haruta et al. in the Colbert et al. system because this would yield multiple beams and hence decrease the processing time required to form a nanotube product.

Intended use has been continuously held not to be germane to determining the patentability of the apparatus, Ex parte Wikdahl 10 USPQ 2d 1546 (BPAI 1989); Ex parte McCullough 7 USPQ 2d 1889, 1891 (BPAI 1988); In re Finsterwalder 168 USPQ 530 (CCPA 1971); In re Casey 152 USPQ 235, 238 (CCPA 1967); Ex parte Masham 2 USPQ 2d. 1647. Duplication of parts was held to have been obvious. In re Harza 124 **USPQ 378.**

Response to Arguments

Applicant's arguments with respect to claims 1-18 have been considered but are moot in view of the new ground(s) of rejection.

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Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to M. Alexandra Elve whose telephone number is 571-272-1173. The examiner can normally be reached on 6:30-3:00 Monday to Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Dunn can be reached on 571-272-1171. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

August 8, 2005.

M. Alexandra Elve

Primary Examiner 1725